



IFW  
H  
CC

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In Re Application of:  
Ming-Fang Wang

Confirmation Number: 1193

Serial No.: 10/662,845

Group Art Unit: 2811  
Examiner: Nguyen, Cuong Quang

Filed: September 15, 2003

TKHR Docket No. 252016-2760  
Top-Team Ref. 0503-A31322US

For: **Method for Forming High-K Dielectric Transistors**

**Certificate of Mailing**

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail, postage prepaid, in an envelope addressed to: Mail Stop Amendment; Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on December 20, 2004.

  
Signature – Hui Chin Barnhill

**AMENDMENT AND RESPONSE TO OFFICE ACTION**

Mail Stop Amendment  
Assistant Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

The Office Action mailed October 20, 2004 has been carefully considered. In response thereto, please enter the following amendments and consider the following remarks.